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8Bb Data Sheet

CONFIRMATION NO. 8712

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| SERIAL NUMBER 10/650,886 | FILING OR 371(c) DATE 08/28/2003 RULE | CLASS 134 | GROUP ART UNIT 1763 | ATTORNEY DOCKET NO. TSM6283131RI |
| APPLICANTS Horng-Wen Chen, Hsin-Chu, TAIWAN; Chi-How Wu, Tainan, TAIWAN; | | | | |
| ** CONTINUING DATA This application is a REI of 09/669,159 09/25/2000 PAT 6,283,131 <i>gag 6-041</i> | | | | |
| ** FOREIGN APPLICATIONS <i>gag 6-041</i> | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/22/2004 | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>gag 6-041</i> | STATE OR COUNTRY TAIWAN | SHEETS DRAWING 6 | TOTAL CLAIMS 58 |
| INDEPENDENT CLAIMS 8 | | | | |
| ADDRESS 25962 | | | | |
| TITLE In-situ strip process for polysilicon etching in deep sub-micron technology | | | | |
| FILING FEE RECEIVED 1984 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |